

**INDUSTRIAL PLASMA ENGINEERING: VOLUME 2:  
APPLICATIONS TO NONTHERMAL PLASMA PROCESSING**

Ewa Quamme

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As indicated in figure Bibcode : PhRvL. If the RF frequency is  
so low that both ions and electrons reach the electrodes and  
recombine, the plasma will either not be initiated or form  
very few coarse filamentary discharges between the plates.  
Moderatedensity-targetremotefromelectrodes.However,totheauthorkno  
The apparatus of claim 24wherein the dimensions of the cavity  
support a TE 1 on mode at the microwave source frequency,  
where n is an integer of at least 3. Third is the moderate  
flow rate regime characterized by increasing excitation of ion  
lines, and decreasing excitation of atomic lines including  
oxygen. This torch may produce an abundance of reactive atomic  
oxygen, and therefore may be used in applications for rapidly  
destroying a broad spectrum of chemical and biological warfare  
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Notalloftheplasmasourcesdiscussedinthetechnicalliteraturehaveprov  
DC, AC, or pulsed high voltage is applied to the electrodes,  
which stimulates electron emission from the instantaneous  
cathode. Accessibility of the intra-particle volume".